

**INFORMATION DISCLOSURE STATEMENT**

Applicant	:	Sherman
App. No	:	10/683,727
Filed	:	October 10, 2003
For	:	SEQUENTIAL CHEMICAL VAPOR DEPOSITION
Examiner	:	Kelly M. Stouffer
Art Unit	:	1762

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 1 reference to be considered by the Examiner. There are no foreign patent references and/or non-patent literature listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed after the mailing date of a final action or after the mailing date of a Notice of Allowance. This Statement is accompanied by the fee set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

**CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)**


I hereby certify that each item of information contained in this Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than 3 months prior to the filing of this Information Disclosure Statement.

**Appl. No.** : 10/683,727  
**Filed** : October 10, 2003

**Docket No.** ASMMC.9CP1DV1C1  
**Customer No.** 20,995

Respectfully submitted,  
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: March 3, 2008

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